Threshold MnAs thickness for the formation of ordered $\alpha/\beta$ stripes in MnAs/GaAs(001)

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To cite this version:
Maurizio Sacchi, Nicolas Casaretto, Leticia Coelho, Mahmoud Edrief, Jialin Ma, et al.. Threshold MnAs thickness for the formation of ordered $\alpha/\beta$ stripes in MnAs/GaAs(001). Journal of Physics D: Applied Physics, IOP Publishing, 2020, 53 (26), pp.265005. 10.1088/1361-6463/ab82da. hal-03028454

HAL Id: hal-03028454
https://hal-cnrs.archives-ouvertes.fr/hal-03028454
Submitted on 27 Nov 2020

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Manganese arsenide layers epitaxially grown on GaAs(001) are known to feature a temperature dependent self-assembled microstructure of ordered stripes, alternating the ferromagnetic \( \alpha \) and paramagnetic \( \beta \) phases. The surface dipolar fields generated by the \( \alpha/\beta \) stripes have been used for achieving temperature controlled magnetization switching of a ferromagnetic overlayer. For this kind of application, it is advantageous to minimize the MnAs layer thickness. In this work we investigate, using x-ray scattering techniques, the presence of the ordered microstructure as a function of the MnAs layer thickness and we identify a minimum value of \( \sim 40 \) nm for the formation of ordered \( \alpha/\beta \) stripes in MnAs/GaAs(001). These results have an impact for envisaging magnetization-switching applications that rely on the control of the temperature- or laser-driven surface dipolar fields in MnAs-based devices.
I. INTRODUCTION

Developing thermally induced magnetization switching (TIMS), where the temperature control of intrinsic material properties drives a deterministic reversal of the local magnetization, has potential for applications. For instance, the combination of materials with different temperature dependent magnetic properties has been used to switch the magnetization with a single laser pulse in rare-earth–transition-metal ferrimagnetic compounds, in a process that combines thermal effects with photon helicity dependent effects \([1-4]\). Controlling the local temperature by a laser pulse is also at the basis of heat assisted magnetic recording processes that were proposed to significantly lower the external field values necessary for switching a magnetic bit \([5]\). A different approach to TIMS makes use of substrates whose intrinsic magnetic properties feature regular spatial modulations generating local surface dipolar fields that can be controlled by tuning the temperature \([6]\). The proof-of-principle of this approach made use of a thin ferromagnetic (FM) Fe layer deposited on a MnAs/GaAs(001) template. MnAs/GaAs(001) is a metal/semiconductor system where the interplay between epitaxial constraints and temperature-driven phase transitions gives rise to a peculiar morphological and magnetic behavior at ambient temperatures \([7, 8]\). At \(T \sim 40^\circ C\), bulk MnAs features a first order transition between ferromagnetic \(\alpha\) and non-magnetic \(\beta\) phases \([9-11]\). In MnAs/GaAs(001) epitaxial films the two phases coexist over the temperature range \(\sim 10–40^\circ C\) in the form of regular stripes \([7, 12]\) the period of which is determined by the MnAs thickness \([7, 8, 13]\) and by the presence of overlayers \([14]\). It was shown that it is possible to control the Fe magnetization in Fe/MnAs/GaAs(001) by fine-tuning the temperature at ambient \([15]\). Element selective x-ray resonant magnetic scattering (XRMS) experiments demonstrated that various magnetic configurations of the Fe/MnAs system can be stabilized predictably by acting on the thermal cycle parameters and on the presence of a bias field \([16]\). What one actually does by changing the temperature is to control the surface dipolar fields associated with the template magnetic microstructure, and, ultimately, vary the effective magnetic field acting on the overlayer. Time-resolved experiments showed the potential of this approach for fast magnetization switching, where the microstructure changes are triggered by a single femtosecond optical laser pulse \([17, 18]\).

The general motivation for this research is to develop a MnAs based two-layer systems for TIMS, where the overlayer magnetization can be switched by temperature control of the dipolar fields generated by the MnAs template. Up to now, TIMS was achieved by employing MnAs
layers 100 to 200 nm thick, but our present understanding of the TIMS process in Fe/MnAs suggests that the advantage of using thinner MnAs layers is at least twofold. Firstly, the stripe period \( p \) is proportional to the film thickness \( t_{\text{MnAs}} \), with \( p \approx 5 \times t_{\text{MnAs}} \) for a bare MnAs film [7, 8], therefore reducing \( t_{\text{MnAs}} \) leads to narrower stripes that can generate stronger surface dipolar fields. A shorter period should also favor a better spatial definition of the TIMS process, since the size of the smallest bit of the overlayer that one can envisage switching independently is proportional to the period. Secondly, it was shown that a fluence threshold exists for laser induced switching, which corresponds to the complete transition of the MnAs film into the high temperature \( \beta \) phase [17, 18]. Therefore a thinner MnAs template should make it possible to switch the overlayer magnetization using lower laser fluence, i.e. a reduced power. Finally, since the characteristic time for magnetization switching is determined by the return towards thermal equilibrium [19], using a thinner template and a lower fluence will lead to a faster switching process.

In summary, reducing the MnAs layer thickness should allow for a faster laser-driven magnetization switching of smaller areas employing a lower power.

The controlled generation and disappearance of surface dipolar fields remains a pre-requisite for TIMS, which for MnAs implies the formation of regular \( \alpha/\beta \) stripes. The occurrence of spatially modulated phase coexistence in thin films has been addressed in theoretical studies. In particular, the work of Sridar et al. [20], which was used for modelling the MnAs/GaAs(001) system [13], suggested that, for certain sets of parameters, the formation of regular stripes becomes unfavorable below a critical thickness of the film. Experimental studies exist on thin MnAs layers on GaAs(001), demonstrating that the crystal structure is well defined and relaxed for films a few nm thick [21] and that the \( \alpha/\beta \) phase coexistence as a function of temperature is observed already for very thin films [22]. Other studies [23-27] report, albeit with some contradictory results, images of the local magnetic order in thin (< 50 nm) MnAs layers. Finally, the role of the layer thickness has been evoked also in connection with the electronic and magnetic properties of ~\( \mu \)-m-sized laterally confined MnAs ribbons [27, 28]. In any case, none of these studies addressed specifically the formation of ordered \( \alpha/\beta \) stripes versus thickness in the limit of very thin MnAs layers.

In this work we employ resonant soft x-ray scattering to study the ordered microstructure as well as the magnetic properties of thin MnAs films. We analyze MnAs/GaAs(001) layers with thickness in the 20-70 nm range. The main objective is to determine the minimum thickness capable of producing a regular microstructure of \( \alpha/\beta \) stripes that can generate at precise and predictable locations the surface dipolar fields necessary for TIMS. Our work confirms the
existence of a threshold thickness for stripe formation; we discuss its possible origin in the framework of previous results reported in the literature.

II. EXPERIMENTAL DETAILS

MnAs layers 20 to 70 nm thick were prepared by molecular beam epitaxy (MBE) on GaAs(001) at the State Key Laboratory of Superlattices and Microstructures of the Institute of Semiconductors (IoS) in Beijing, following a well-established protocol [29, 30]. The samples were capped by ~4 nm of GaAs for protection against contamination. As a reference, we measured also two samples prepared at the Institut des NanoSciences de Paris (INSP) that were used in previous experiments, one 30 nm thick [27], the other 180 nm thick [19]. All samples were characterized by x-ray diffraction (XRD) measurements at INSP, using the Cu-Kα1 radiation from a rotating anode diffractometer equipped with a Ge(220) 2-reflection channel-cut monochromator. XRD data confirmed the growth of type-A MnAs layers [7], with the epitaxial relationship between MnAs and GaAs sketched in figure 1(a).

Soft x-ray resonant scattering measurements were performed at the Circular Polarization beamline of the ELETTRA synchrotron (Trieste), using the IRMA scattering chamber [31]. The sample holder was equipped for temperature and magnetic field control. A photodiode with a 0.2 mm vertical aperture slit was placed on the detector arm at 150 mm from the sample. An in vacuum 2D detector, based on microchannel plates and a resistive anode, was mounted on a fixed flange (central scattering angle 20 ≈ 32.5°) and allowed us to collect the diffuse intensity around the specular beam and the diffraction peaks originating from the regular stripe microstructure. Scattering measurements were performed in co-planar geometry [see figure 1(b)], tuning the soft x-ray energy to the Mn-2p resonance (~640 eV). In addition to providing a stronger diffraction signal from the ordered stripes, working at the Mn core resonance and using circularly polarized radiation allowed us to probe also the magnetic response as a function of temperature under the same experimental conditions.

The formation of regular stripes alternating the α and β phases was monitored by probing the scattered intensity around the specular beam either by using the 2D detector or by performing sample rocking scans using the slitted photodiode. In both cases, the regular stripes produce Bragg peaks the angular location of which depends on the stripe period p, on the x-ray wavelength λ, and on the incidence (ω) and scattering (2θ) angles.
Taking (x,y) as the sample surface and (x,z) as the incidence plane [see figure 1(b)], the exchanged momentum vector has components \( q_x = (4\pi/\lambda) \cdot \sin(\theta) \cdot \sin(\alpha) \), \( q_y = 0 \) and \( q_z = (4\pi/\lambda) \cdot \sin(\theta) \cdot \cos(\alpha) \), where \( \alpha = \omega - \theta \) is the sample off-specular angle. Figure 1(c) shows schematically in a \((q_x,q_z)\) chart the location of Bragg peaks at \( q_x = 2\pi/p \) for a stripe period \( p = 300 \text{ nm} \), observed with a photon energy of 640 eV (\( \lambda = 1.94 \text{ nm} \), Mn-2p resonance). On the same chart we have highlighted the lines corresponding to a detector scan and to a sample rocking scan. The former (blue dash-dot line) corresponds to a \( 2\theta \) scan at fixed \( \omega \) (in our case, to a 2D-detector acquisition), the latter (red dotted line) to a \( \omega \) scan at fixed \( 2\theta \) (i.e., to a \( q_x \) scan at almost constant \( q_z \)). In our measurements we could also cover whole areas of the \((q_x,q_z)\) chart by combing \( \omega \) scans collected at different \( 2\theta \) angles, using the slitted diode detector.
Table 1 lists all the samples addressed specifically in this study and compares their nominal MnAs thickness values with those obtained by soft (synchrotron) and hard (Cu-Kα) x-ray reflectivity. In the following, we will refer to each sample by its nominal thickness value.

<table>
<thead>
<tr>
<th>$t_{\text{nominal}}$ (nm)</th>
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<td>180</td>
<td>180</td>
<td>179</td>
<td>INSP</td>
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### III. RESULTS

Figure 2 shows for all samples the temperature dependence of the Mn magnetization in a heating cycle, measured by Mn-2p resonant magnetic scattering. The magnetic signal is defined as the difference between the scattered intensity recorded for opposite magnetization/helicity orientations divided by their sum [16].

The curves in figure 2, normalized to 1 at $T = -10$ °C for better comparison, show an identical behavior as a function of temperature, with only the $t_{\text{MnAs}} = 20$ nm sample featuring a slightly different slope. For all samples, the magnetization vanishes at around 40 °C, i.e. at the temperature corresponding to the transition to the $\beta$ phase in bulk MnAs. The magnetization
curves of figure 2 confirm also that all samples were aligned with their easy magnetization axis within the incidence plane, which is the correct azimuth for observing stripes-related Bragg peaks in our co-planar geometry.

Figure 3 shows the experimental results obtained for the reference 180 nm thick MnAs sample. The 2θ scan at fixed $\omega$ [2D-detector acquisition, figure 3(a,b)] shows the presence of Bragg peaks at $q_x \approx 7 \mu m^{-1}$ corresponding to a period of $\sim 900$ nm, in perfect agreement with the expected $p \approx 5 \times t_{MnAs}$ relationship. The association of the Bragg peaks with the formation of regular $\alpha/\beta$ stripes is further supported by the temperature dependence of their intensity over a heating cycle from 0 to 50 °C, shown in figure 3(c).

Coming to the thin MnAs layers, figures 4–7 summarize the results for $t_{MnAs}$ between 20 and 70 nm.

Neither the rocking scans nor the 2D images in figure 4 show any Bragg peak at the expected position for $t_{MnAs} = 20$ nm. In the $(q_x,q_z)$ chart of figure 4(a), no additional intensity corresponding to the expected stripe period is observed at any $q_z$ value. Figure 4(b) shows identical curves for data collected at 22 °C, where both $\alpha$ and $\beta$ phases coexist (red squares) and at 55 °C, where the MnAs is $\beta$-only and no stripes are expected (black circles). Figure 4(c) compares 2θ scans recorded at three temperature values in a heating-cooling sequence from 30 °C ($\alpha/\beta$ coexistence) to 77 °C (pure $\beta$ phase) and back to 20 °C ($\alpha/\beta$ coexistence): no variation can be detected above the noise level.

Figure 3. Soft x-ray scattering results for the $t_{MnAs}=180$ nm reference sample. All data were collected at 640 eV photon energy ($\lambda=1.94$ nm), corresponding to the Mn-2p resonance. (a) 2D detector acquisition with $\omega=16.25^\circ$. (b) Detector scan curve obtained by vertical integration of (a). (c) Temperature dependence of the 1$\text{st}$ order peak intensity.
Figure 4. Resonant scattering results for the $t_{\text{MnAs}} = 20$ nm sample. Dashed vertical lines locate the expected Bragg peak position for $p = 5 \times t_{\text{MnAs}} = 100$ nm. (a) Room-temperature ($q_x, q_z$) chart obtained by a sequence of rocking scans performed at different 2θ values. The specular ridge is saturated. (b) Rocking curves at $q_z = 0.898$ nm$^{-1}$ measured at T = 22 °C and T = 55 °C. Their ratio (blue curve, ×5) is also shown. (c) 2D detector acquisitions ($\omega = 18^\circ$) and corresponding $q_x$ line profiles measured at three temperatures in the sequence T = 30 °C → 77 °C → 20 °C.

One can draw the same conclusion for the 35 nm sample, the rocking curves of figure 5(a) and 2D-detector acquisitions of figure 5(b) showing no Bragg peak and no temperature dependence. These measurements demonstrate that no signal can be related to the formation of a temperature dependent ordered microstructure alternating the $\alpha$ and $\beta$ phases in the 20 nm and 35 nm thick samples.

Figure 5. Scattering data for the $t_{\text{MnAs}} = 35$ nm sample.
(a) Rocking curves at T = 25 and 55 °C (2θ= 16°), and their intensity ratio (blue curve, ×5). (b) 2D detector acquisitions (ω = 15.25°) and corresponding $q_x$ line profiles measured at T = -3 and +23 °C. The vertical lines locate the Bragg peak positions expected for a stripe period $p = 5 \times t = 175$ nm.
The scattering measurements give a different picture for the thicker 50 nm and 70 nm samples. Figure 6(a) shows a room-temperature \((q_x, q_z)\) chart for \(t_{\text{MnAs}} = 50\) nm, featuring diffracted intensity at \(q_x\) values around \(\pm 0.024\) \(\text{nm}^{-1}\), strongly enhanced at \(q_z \approx 0.85\) \(\text{nm}^{-1}\). Figure 6(b) shows the 2D-detector diagrams measured at \(T = 23\) °C and \(T = 55\) °C, and the corresponding \(q_z\) line profiles. Clear peaks are observed at room temperature, where both \(\alpha\) and \(\beta\) phases are present, and they disappear when the sample is heated above the temperature for the transition to the \(\beta\) phase.

![Figure 6](image_url)

Finally, figure 7 shows the results for the 70 nm sample: strong peaks are measured at room temperature, which disappear by either reducing (\(T = -7\) °C, \(\alpha\)-MnAs only) or increasing (\(T = +57\) °C, \(\beta\)-MnAs only) the temperature.

### IV. DISCUSSION

From the ensemble of the results presented in figures 4–7, we conclude that there is a critical value of the MnAs layer thickness for observing the formation of ordered \(\alpha/\beta\) stripes over the temperature region characterized by phase coexistence, and that this value is around 40 nm. In
the following, we will correlate this finding with data reported previously by other authors and with the results of complementary x-ray diffraction measurements.

First of all, one should mention that several studies exist that report magnetic images of thin MnAs layers obtained by either magnetic force microscopy (MFM) or by x-ray photoelectron emission microscopy (X-PEEM). Although none of them addresses the issue of stripe formation versus thickness explicitly, some of the reported results are worth discussing here.

In two of the early X-PEEM works on MnAs/GaAs(001), the magnetic images of a 37 nm [23] and of a 40 nm [24] layer showed a clear array of nonmagnetic β stripes at room temperature. These observations may help us setting an upper limit to the thickness at which ordered stripes are not formed anymore. One must notice, though, that the periods that can be extracted from the X-PEEM images are ~250 nm for the 37 nm sample (figure 1 of reference [23]) and ~350 nm for the 40 nm one (figure 3 of reference [24]). These values exceed (the former only slightly) what is expected for a ~40 nm MnAs layer, suggesting that the thicknesses of these samples may had been underestimated.

A much lower value may be inferred from the MFM work of Fraser et al. [26], which mentions the presence of α/β stripes with a period of 230 nm in a 10 nm thick sample. Unfortunately, no
image is provided in the article to support this statement. Moreover, such a large period-to-thickness ratio seems unlikely.

A recent X-PEEM study [27] compared room temperature magnetic images for 30 and 50 nm thick samples (figure 3 of reference [27]). Regular non-magnetic β stripes running perpendicular to the easy magnetization direction are evident for the 50 nm thick MnAs layer, but they are absent in the 30 nm one. This observation, obtained by a completely different experimental method (X-PEEM), not only agrees with and supports the conclusions of our study, but also proves that these conclusions do not depend on the specific technique (XRMS) that we have employed.

Finally, it should be mentioned also that the investigation of both the magnetic domain structure [25] and of the electrical properties [28] of MnAs films in the low thickness limit suggest a change in behavior across the 20 – 50 nm range. These results may be related to microstructural changes and generally agree with our findings.

Based on the results of our work alone, we cannot provide a clear explanation for the absence of ordered stripes below a certain thickness of the MnAs layer. In the following, we will discuss some hypotheses.

The first one concerns a possible relationship with crystalline quality. The initial stages of the MnAs growth on GaAs(001) were addressed in previous works by following the structural evolution in situ [21, 32]. It was shown in particular that the width of the rocking curves measured at scattering angles that match the MnAs Bragg peaks decreases when the layer thickness increases [33], a result that was associated with the improved grain size, crystal quality and long range order in the film. Therefore, it seems appropriate to question whether the ~40 nm critical value for observing ordered α/β stripes is related to the crystalline quality of the film.

A feature common to all our samples regardless of their thickness is the presence of both α and β phases at room temperature. Using Cu-Kα radiation, we performed ω-scans (i.e., rocking curves) at 2θ values corresponding to the 006 Bragg peaks (in orthorhombic notation) of the α and β phases. Figure 8(a-d) shows the rocking scans measured at 2θα and 2θβ for four MnAs layers. The 30 nm sample of figure 8(d) is the same of the X-PEEM experiment of ref. [27]. The value w of the full angular width at half maximum (FWHM), averaged over the α and β peaks, is reported for each sample. Figure 8(e) summarizes the w values obtained for a larger set of samples, showing the general trend of a decreasing FWHM as the thickness increases. It is also observed, though, that w values depend strongly on the growth process details: each symbol in
figure 8(e) identifies samples prepared during a single growth session, showing that, depending on the growth conditions, very small $w$ values can be obtained also for thin layers. The two samples of figure 8(c,d) have similar thicknesses (35 and 30 nm): although they feature rather different rocking curve widths of 0.77° and 0.36°, stripes are absent for both of them. The samples of figure 8(b,c), 50 and 35 nm thick prepared during the same growth session, feature almost identical rocking curve widths ($w \approx 0.75°$), but behave differently in terms of stripe formation (see figures 5 and 6).

Overall, the ensemble of our data points unequivocally to the absence of a correlation between the crystalline quality of the MnAs layer, at least as measured by $w$, and the presence or absence of ordered $\alpha/\beta$ stripes.

Figure 8. (a-d) Room temperature rocking curves ($\omega$-scans) measured for four different samples with 2θ set at the 006 peaks of $\alpha$ (■) and $\beta$ (○) MnAs. The $w$ values reported for each sample correspond to the FWHM averaged for $\alpha$ and $\beta$ peaks. (e) Summary of $w$ values for a wider set of MnAs samples as a function of their thickness. Each symbol identifies a subset of samples prepared during a single growth session.
Since the step height $h$ between $\alpha$ and $\beta$ stripes is proportional to the MnAs layer thickness ($h$ is \( \sim 1\% \) of $t_{\text{MnAs}}$), one can speculate that reducing the film thickness may make the diffraction peaks too weak to be observed by XRMS. Moreover, also the period $p$ diminishes with $t_{\text{MnAs}}$, and in the theoretical work of Kaganer and collaborators [13] it was predicted that the narrowing of the stripes could lead to a further smoothing of the steps between $\alpha$ and $\beta$ domains, accompanied by the convergence towards a common value of the vertical lattice spacing for the two phases. This last prediction is at variance with our observation of clearly distinct 00$l$ diffraction peak positions for $\alpha$ and $\beta$ MnAs down to the thinnest layer that we measured. Moreover, it is worth stressing that the X-PEEM observations mentioned above [27] are not affected by the step height $h$, since they rely only on the magnetic contrast between ferromagnetic $\alpha$ and paramagnetic $\beta$ phases. Therefore, it seems unlikely that the disappearance of stripes in XRMS data and X-PEEM images when reducing the layer thickness below 40 nm can originate simply from the reduction of the steps height.

Another possible explanation for the existence of a threshold thickness compatible with experimental observations may come from the loss of the vertical homogeneity in the MnAs layer. Fu et al. [34] report a transmission electron microscopy (TEM) study showing a depth dependent strain field in a 180 nm thick MnAs lamella, which may lead to an inhomogeneous phase transition. Another TEM work that analyzes the vertical magnetization profile in a 180 nm thick MnAs lamella [35] shows a reduced magnetization at the interfaces with the GaAs(001) substrate and with the capping layer, suggesting a temperature dependent inhomogeneous spatial distribution of the $\alpha$ phase in the layer depth. The impact of such observations would be enhanced for thinner films, where a loss of structural homogeneity in the vertical direction, combined with the smaller lateral size of the domains, may hamper the formation of regular $\alpha/\beta$ stripes. These observations should be tempered by two remarks: i) Fu et al. conclude that the TEM sample preparation may well be at the origin of the observed change in film properties; ii) inhomogeneous magnetization profiles in MnAs films were reported earlier, but they were attributed to the inhomogeneity of the magnetization vector orientation, rather than to its modulus [12, 36], which has only minor or no implication on the structural homogeneity. Finally, let us also remind that our structural and magnetic data show clearly that the $\alpha$-phase persists over the same temperature range regardless of the layer thickness (figure 2), ruling out a premature disappearance of the $\alpha$-phase with temperature in the thinner layers.
V. CONCLUSIONS

From the ensemble of our results we can draw two main conclusions. Firstly, the thickness of the MnAs film certainly matters in defining the presence or absence of regular α/β stripes at ambient temperature, with a threshold value that we determine to be around 40 nm. Secondly, the crystalline quality of the MnAs layer, at least as measured by the width of the rocking curves, does not seem to play a fundamental role, if any at all, in the definition of this threshold value.

On the one hand, these results will be very useful in the preparation of future experiments that use the MnAs/GaAs(001) system as the template material for the magnetization control of a ferromagnetic overlayer. In particular, they will be instrumental to envisaging any application that relies on the control of the temperature- or laser-driven surface dipolar fields for attaining magnetization switching. On the other hand, our results do not clarify the mechanisms leading to the existence of a critical thickness. Analyzed together with previously published results, though, they allowed us to discuss and possibly discard some hypotheses.

The most realistic picture for explaining the absence of ordered stripes in very thin MnAs layers seems to involve a loss of vertical structural coherence due to the simultaneous reduction of the thickness and of the lateral domain size. Although this view is not fully supported by experiments yet, it explains the results of all our XRMS measurements and also of previous experiments. Further X-PEEM and sectional TEM images may be helpful to validate this picture. On the theory side, an extension of the model calculations proposed in the seminal work of Kaganer et al. [13] and based on the work of Sridhar et al. [20] would provide a firmer theoretical support for understanding the absence of ordered α/β stripes in the low thickness limit of MnAs films on GaAs(001).

ACKNOWLEDGEMENTS

We acknowledge Sincrotrone Trieste for granting beamtime to our project and the Circular Polarization beamline staff for assistance during the experiment. The research leading to these results has been supported by the project CALIPSOplus under Grant Agreement 730872 from the EU Framework Programme for Research and Innovation HORIZON 2020. We acknowledge the support from the National Natural Science Foundation of China under Grant No. U1632264.
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Free-Electron-Laser probe scattering experiment

Photonics, 4, 21 (2017).
doi:10.3390/photonics4020021


